



ITW

Docket No.: 52775-025

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Masahiro NAKAYAMA, et al. : Confirmation Number: 6895
Application No.: 10/665,483 : Group Art Unit: 1772
Filed: September 22, 2003 : Examiner: Alexander S. Thomas
For: NITRIDE SEMICONDUCTOR WAFER AND METHOD OF PROCESSING NITRIDE
SEMICONDUCTOR WAFER

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of October 14, 2004 wherein restriction has been required, Applicant hereby elects Group II (claims 10-20) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,
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